IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Hajime YAMAMOTO, et al.**

Serial Number: **Not Yet Assigned**

Filed: **August 26, 2003**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND METHOD OF FORMING RESIST PATTERN**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 26, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (1)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. **031029**	Serial No. **New Application**
	Applicant(s): **Hajime YAMAMOTO, et al.**	
	Filing Date: **August 26, 2003**	Group Art Unit: **Not Yet Assigned**

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA						
_____	AB						
_____	AC						
_____	AD						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
_____	AE	10-73927	03/17/98	Japan	Yes-Abstract
_____	AF				
_____	AG				
_____	AH				
_____	AI				

OTHER DOCUMENTS

_____	AJ	
_____	AK	

Examiner	Date Considered